

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1734

Examiner: Not yet assigned



In Re PATENT APPLICATION Of:

Applicants: Toshikazu YAMAUCHI

Serial No.: 10/670,725

Filed: September 26, 2003

For: PHOTORESIST APPLYING DEVICE  
AND APPLYING METHOD THEREFOR

Docket No.: OKI 378

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)  
)  
) **INFORMATION**  
) **DISCLOSURE**  
) **STATEMENT**

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January 21, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97 (b)(3), i.e., prior to a First Office Action on the Merits.

Attached is a copy of one (1) Japanese Publication together with its English-language Abstract. Any relevance of this document can be gleaned from the attached English-language Abstract. The document is listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed before the First Office Action on the merits, no fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted document is respectfully requested.

Respectfully submitted,

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RHB:crh

FORM PTO-1449

## INFORMATION DISCLOSURE STATEMENT

Atty. Docket:  
OKI 378Application No.:  
10/670,725Applicant:  
Toshikazu YAMAUCHIFiling Date:  
September 26, 2003Group Art Unit:  
1734

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	09206584 A	08/12/97	Japan			Abstract
	AJ						
	AK						
	AL						
	AM						

## OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	
	AO	

Examiner

Date Considered

EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

